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UNITED STATES PATENT AND TRADEMARK OFFICE
WASHINGTON, D.C. 2023I
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**CONFIRMATION NO. 2584** 

**Bib Data Sheet FILING DATE ATTORNEY GROUP ART UNIT** CLASS **SERIAL NUMBER** DOCKET NO. 02/19/2002 2812 10/076,653 111984 2653 RULE **APPLICANTS** Ikuhito Onodera, Chuo-ku, JAPAN; \*\* CONTINUING DATA \*\*\*\*\*\*\*\*\*\*\*\*\*\*\*\*\*\* \* FOREIGN APPLICATIONS \*\*\*\*\*\*\*\*\*\*\*\*\*\* (LNJAPAN 2001-057673 03/02/2001 IF REQUIRED, FOREIGN FILING LICENSE GRANTED \*\* 03/12/2002 Foreign Priority claimed ves 🔲 no INDEPENDENT STATE OR SHEETS TOTAL yes on no Metafter 35 USC 119 (a-d) conditions **CLAIMS DRAWING** CLAIMS COUNTRY met P Allowance 2 **JAPAN** 18 Verified and **Acknowledged** Examiner's Signature **ADDRESS** 25944 TITLE Method for fabricating a thin film magnetic head and wafer structure 🖵 Ali Fees 🛏 1.16 Fees ( Filing ) 1.17 Fees ( Processing Ext. of FEES: Authority has been given in Paper **FILING FEE** No. \_\_\_\_\_ to charge/credit DEPOSIT ACCOUNT time) **RECEIVED** for following: 740 **⊔** 1.18 Fees ( Issue ) Other Credit